



SLW

Docket No.: 4006-284

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of (1) :
Inventor(s): Wen-Jian LIN :
U.S. Patent Application No. 10/810,660 : Group Art Unit: -----
Filed: March 29, 2004 : Examiner: -----

For: A STRUCTURE OF A MICRO ELECTRO MECHANICAL SYSTEM AND THE
MANUFACTURING METHOD THEREOF

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

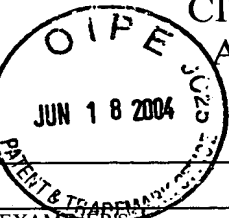
This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

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<div>INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)</div> <div></div>		ATTY. DOCKET NO. 4006-284		U.S. PATENT APPLICATION NO. 10/810,660			
		APPLICANT Wen-Jian LIN					
		FILING DATE March 29, 2004		GROUP			
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
	5,835,255	Nov. 10, 1998	Miles				
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.